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# High photoresponsivity and broadband photodetection with a band-engineered WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure†

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van der Waals (vdW) heterostructures formed by stacking different two-dimensional layered materials have been demonstrated as a promising platform for next-generation photonic and optoelectronic devices due to their tailorable band-engineering properties. Here, we report a high photoresponsivity and broadband photodetector based on a WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure. By properly biasing the heterostructure, its band structure changes from near-broken band alignment to type-III band alignment which enables high photoresponsivity from visible to telecommunication wavelengths. The highest photoresponsivity and detectivity at 532 nm are  $\sim 588 \text{ A W}^{-1}$  and  $4.4 \times 10^{10}$  Jones and those at 1550 nm are  $\sim 80 \text{ A W}^{-1}$  and  $1.4 \times 10^{10}$  Jones, which are superior to those of the current state-of-the-art layered transition metal dichalcogenides based photodetectors under similar measurement conditions. Our work not only provides a new method for designing high-performance broadband photodetectors but also enables a deep understanding of the band engineering technology in the vdW heterostructures possible for other applications, such as modulators and lasers.

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## Introduction

Recently, two-dimensional (2D) layered materials have received significant attention for photodetection applications due to their high optical absorption,<sup>1–10</sup> high carrier mobility and good flexibility.<sup>11–16</sup> For example, semiconducting transition metal dichalcogenides (TMDs, such as MoS<sub>2</sub>, WSe<sub>2</sub>, MoS<sub>2</sub> and MoSe<sub>2</sub>) are considered as promising candidates for future photodetection applications.<sup>17</sup> Indeed, photodetectors with TMDs have been demonstrated with high photoresponsivity (e.g.,  $800 \text{ A W}^{-1}$  at 561 nm with monolayer MoS<sub>2</sub>).<sup>18</sup> However, the previously reported operation bandwidth of a TMD-based photodetector is typically limited by the bandgap of the TMD

material. For example, the bandgap of MoS<sub>2</sub> is between  $\sim 1.2$  eV (bulk) and  $\sim 1.8$  eV (monolayer).<sup>19,20</sup> Therefore, in principle, a MoS<sub>2</sub> based photodetector typically cannot effectively detect light with a photon energy smaller than 1.2 eV. Such an intrinsic bandgap limitation poses a great challenge for various photonic applications (e.g., telecommunications).

van der Waals (vdW) heterojunctions, formed by stacking different individual 2D layered materials, can offer a new dimension in breaking the abovementioned intrinsic bandgap barrier.<sup>21–31</sup> In general, three types of band alignments can be categorized when different 2D materials are stacked together,<sup>32</sup> including type-I,<sup>33</sup> type-II,<sup>34–38</sup> and type-III<sup>39–43</sup> band alignments. Thus far, most of the reported vdW heterostructure photodetectors are based on the type-II band alignment to utilize the excellent electron–hole pair separation ability in heterostructures. Recently, type-III band alignment has been explored as a platform for tunneling field effect transistors (TFETs) due to its enhanced tunneling current density.<sup>40,44–49</sup> The 2D layered materials based type-III band alignment TFETs with improved responsivity and detectivity have been the focus of many recent studies in the visible wavelengths (e.g.  $5.7 \text{ A W}^{-1}$  under 660 nm,<sup>50</sup>  $244 \text{ A W}^{-1}$  under 550 nm,<sup>51</sup>  $180 \text{ A W}^{-1}$  under 405 nm<sup>47</sup>). However, the applications of the type-III band alignment TFETs in the field of broadband photodetection have rarely been reported. In this paper, we report a high photoresponsivity and broadband photodetector based on a WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure. By applying a large negative

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†Electronic supplementary information (ESI) available: (1) AFM image of a heterostructure, (2) Raman spectra of the heterostructure, (3) electrical characteristics of WSe<sub>2</sub> and SnSe<sub>2</sub> based FETs, (4) photoresponsivity comparison of this work and previous results, (5) photo-switching characteristics of the device. See DOI: 10.1039/c8nr09248f



gate voltage and a reverse bias voltage, the heterojunction band structure changes from type-II to type-III band alignment and a band-to-band tunneling phenomenon occurs. The increased band bending at the heterojunction results in the tunneling-assisted transition which possibly allows photocurrent generation with energy smaller than the bandgap of WSe<sub>2</sub> (e.g., 980 nm and 1550 nm) for broadband photodetection (e.g. photo-excited electron tunnel from WSe<sub>2</sub> to the conduction band of SnSe<sub>2</sub>). Under the type-III band alignment conditions, our heterojunction device shows a high photo-responsivity up to  $\sim 588 \text{ A W}^{-1}$  at a wavelength of 532 nm and  $\sim 80 \text{ A W}^{-1}$  at a wavelength of 1550 nm. The corresponding photodetectivity reaches  $4.4 \times 10^{10}$  Jones and  $1.4 \times 10^{10}$  Jones for visible and telecommunication wavelengths, respectively.

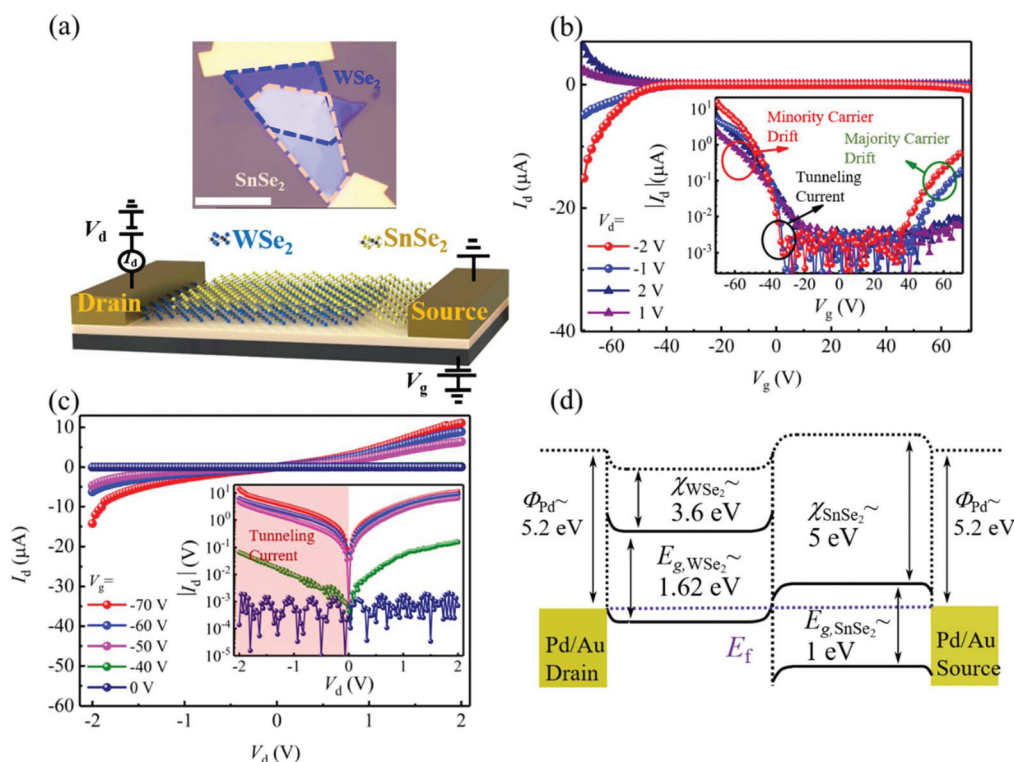
## Results and discussion

The optical image and schematic illustration of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure device are shown in Fig. 1a. Few-layer p-type WSe<sub>2</sub> and n-type SnSe<sub>2</sub> flakes, mechanically exfoliated from their bulk materials, are transferred onto a 280 nm SiO<sub>2</sub>/silicon substrate. An overlapping heterojunction region is formed by precisely controlling their locations. Pd/Au metal contacts (20/50 nm) are patterned onto the WSe<sub>2</sub> and SnSe<sub>2</sub> flakes to collect holes and electrons. The thicknesses of the

WSe<sub>2</sub> and SnSe<sub>2</sub> few-layer flakes are determined by atomic force microscopy (AFM), giving the values of 6 nm and 15 nm, respectively (ESI Fig. S1†). Raman spectroscopy is employed to confirm the high quality of our device after the fabrication processes (ESI Fig. S2†).

Before testing the electrical characteristics of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure, we also fabricated two individual WSe<sub>2</sub> and SnSe<sub>2</sub> based field effect transistors (FETs) to analyze the properties of WSe<sub>2</sub> and SnSe<sub>2</sub>. WSe<sub>2</sub> and SnSe<sub>2</sub> FETs are fabricated on Si/SiO<sub>2</sub> substrates with Pd/Au (20/50 nm) as the drain and source electrodes. The transfer curves of the FETs (ESI Fig. S3†) show p-type characteristics for WSe<sub>2</sub> and n-type characteristics for SnSe<sub>2</sub>, indicating that Pd can efficiently inject holes into WSe<sub>2</sub> and electrons into SnSe<sub>2</sub> when a negative gate voltage is applied.<sup>41,52</sup> Moreover, the nonlinear output results of the WSe<sub>2</sub> flake (ESI Fig. S3b†) indicate the existence of a Schottky barrier at the contact region, while the SnSe<sub>2</sub> results (ESI Fig. S3d†) indicate that an ohmic contact is formed between Pd and SnSe<sub>2</sub>. Note that, since SnSe<sub>2</sub> is a degenerated n-doped semiconductor, the band alignment of SnSe<sub>2</sub> at the interface would be relatively unaffected by the  $V_g$  (see ESI Fig. S3c†).<sup>35,43</sup>

Next, the electronic properties of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterojunction is studied. The device is characterized by applying a constant drain to source voltage ( $V_d$ ) and a gate voltage ( $V_g$ ) in the configuration shown in Fig. 1a. The device shows obvious p-type transport characteristics. The concentration and the



**Fig. 1** The WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure device and its electronic properties. (a) Microscopy image (upper panel) and schematic illustration (bottom panel) of the heterojunction device. (b)  $I_d$ - $V_g$  characteristics measured with variable  $V_d$  in the dark. Inset:  $|I_d|$ - $V_g$  characteristics on the logarithmic scale. (c)  $I_d$ - $V_d$  characteristics measured with variable  $V_g$  in the dark. Inset:  $|I_d|$ - $V_d$  characteristics on the logarithmic scale. (d) The schematic band diagrams of the heterojunction. The scale bar is 10  $\mu\text{m}$ .



type of the carriers can be tuned by  $V_g$ , at  $V_d = -2$  V; the  $I_d$ - $V_g$  result shows the gate-controlled current, with an on-off ratio of  $\sim 10^4$  (see Fig. 1b). The reverse current ( $I_{\text{reverse}}$ ,  $V_d < 0$  V) at  $V_g < -30$  V is the band-to-band tunneling (BTBT) current, whose magnitude increases as the gate voltage decreases. The magnitude of  $I_{\text{reverse}}$  at  $V_g > 40$  V increases as the gate voltage increases due to the majority carrier drifting. The forward current ( $I_{\text{forward}}$ ,  $V_d > 0$  V) observed at  $V_g < -30$  V can be attributed to the drifting of the minority carriers (see the discussion below). The magnitude of the reverse current increases with both positive and negative  $V_g$  and the maximum of the reverse current is 15  $\mu$ A when  $V_d = -2$  V and  $V_g = -70$  V. The gate-dependent current-voltage ( $I_d$ - $V_d$ ) characteristics are shown in Fig. 1c, where two important features can be observed. First, owing to the ultrathin thickness nature of the heterojunction, the magnitude of both  $I_{\text{forward}}$  and  $I_{\text{reverse}}$  can be significantly controlled by modifying the gate voltage. Second, since the breakdown voltage (*i.e.*  $-0.01$  V) is very much less than  $4E_g/q$ , where  $E_g$  is the band gap of the semiconductors (1.62 eV of WSe<sub>2</sub> and 1 eV of SnSe<sub>2</sub>) and  $q$  is the electron charge, the tunneling current (red region in the inset of Fig. 1c) can be attributed to Zener tunneling.<sup>53</sup>

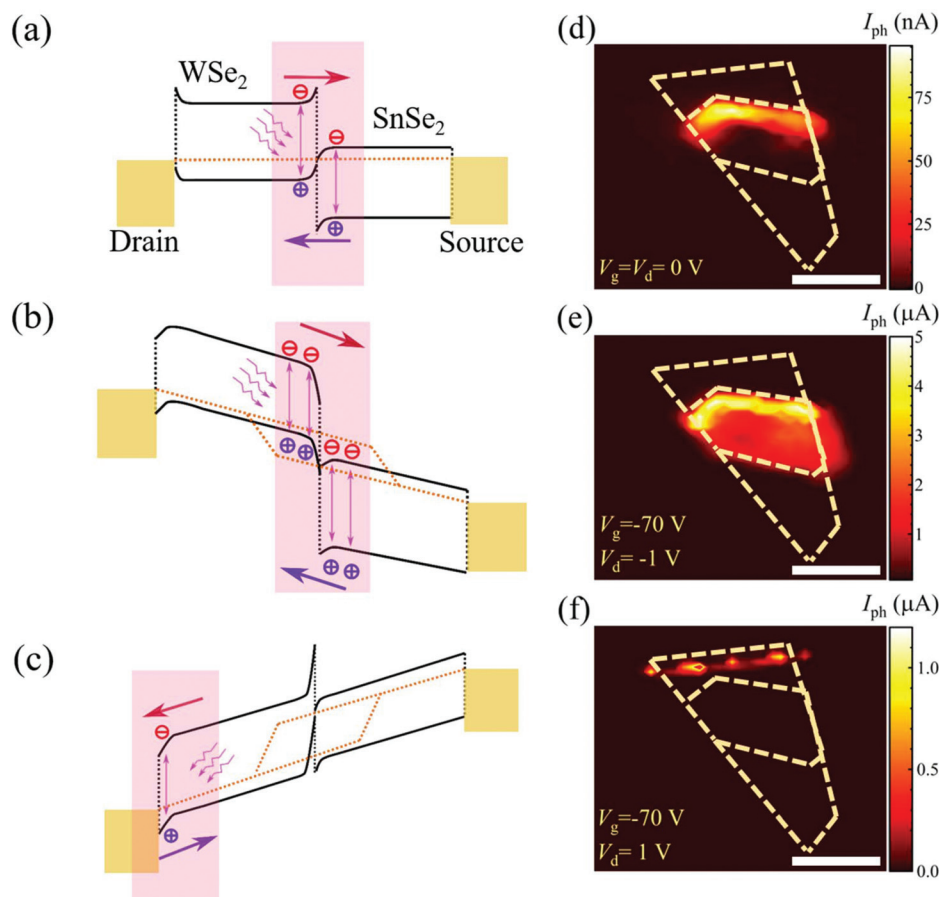
The qualitative band alignment of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure at zero bias is sketched in Fig. 1d based on the reported electron affinity values in the literature.<sup>54,55</sup> Based on these values, a nearly broken band alignment is formed, where the Fermi level of WSe<sub>2</sub> locates at the edge of its valence band and that of SnSe<sub>2</sub> locates at the edge of its conduction band. The heterostructure resembles a p-n diode with a staggered band gap offset. The bottom of the conduction band and the top of the valence band of WSe<sub>2</sub> (SnSe<sub>2</sub>) are at 3.6 eV (5.22 eV) and 5 eV (6 eV), so that the offsets of the conduction band and valence band are about 1.4 eV and 0.78 eV, respectively.

The transfer characteristics of the heterostructure can be understood through band diagrams (Fig. 2a-c). When there is no gate voltage (*i.e.*  $V_g = 0$  V), as shown in Fig. 2(a), the high Schottky barrier at the drain contact and the high difference of the conduction/valence band discontinuity restrain the current flow, leading to the zero dark current. Under these conditions, the device can be seen as a Schottky diode in series with a p-n junction and a resistor. When a negative gate voltage is applied (*i.e.*  $V_g < -30$  V) as shown in ESI Fig. S3b,<sup>†</sup> the doping level of WSe<sub>2</sub> is increased and a near-ohmic contact is formed at the drain contact (the band bending direction at the drain contact shifts downwards). Thus, the model of the device under these conditions can be described as two resistors in series with a p<sup>+</sup>n junction. Therefore, when a reverse bias is applied (Fig. 2b), the valence band maximum of WSe<sub>2</sub> shifts above the conduction band minimum of SnSe<sub>2</sub>, and the type of the band structure changes from near broken band alignment to broken band alignment (type-III). Thus, the electrons in the valence band of WSe<sub>2</sub> can tunnel into the conduction band of the SnSe<sub>2</sub> flake. This tunneling current can then be increased by increasing the reverse bias voltage, see Fig. 1c, due to the enlarged overlapping energy level between the valence band of WSe<sub>2</sub> and the conduction band of SnSe<sub>2</sub>.

However, when a forward bias is applied (Fig. 2c), the band alignment changes from type-III to type-II, the barrier height at the heterojunction is reduced, and the majority carriers (electrons in SnSe<sub>2</sub> and holes in WSe<sub>2</sub>) can overcome the interface barrier and drift to their counterparts, leading to a high forward current. The carrier transportation under the forward bias conditions follows the mechanism as described for the traditional p-n diode, where the forward current increases exponentially with forward bias.<sup>40</sup> To further analyze the transfer characteristics of the heterostructure, scanning photocurrent mapping at  $\lambda = 532$  nm under a confocal optical microscope (objective 100 $\times$ , NA = 0.75,  $P_{\text{laser}} = 50$   $\mu$ W (corresponding to a power intensity of  $8.5 \times 10^3$  W cm<sup>-2</sup>)) was performed, as shown in Fig. 2d-f. The spot size ( $\sim 0.6$   $\mu$ m<sup>2</sup> at 532 nm) of the incident laser is much smaller than the size ( $\sim 50$   $\mu$ m<sup>2</sup>) of the heterojunction. When there is no bias (*i.e.*  $V_g = V_d = 0$  V), as mentioned above, the heterostructure resembles a p-n junction. Thus, when there is an external light excitation, electron-hole pairs will be generated and separated efficiently at the heterojunction (Fig. 2d) where the photo-generated electrons move to the SnSe<sub>2</sub> flake while the holes move to the WSe<sub>2</sub> flake, due to the built-in electric field.<sup>56</sup> The part of the heterojunction near the drain contact shows a stronger photocurrent, which has also been observed in ref. 57, and can be attributed to the lower sheet resistance of this region compared to those of other parts. Note that the photocurrent mapping results only indicate the region where the dominant photocurrent is generated. A small photocurrent (*e.g.*,  $\sim 1$  nA in Fig. 2d) can be observed in the drain part of the device. Under reverse bias with a negative  $V_g$ , the  $I_d$  is governed by the BTBT, where carriers from the valence band of the WSe<sub>2</sub> tunnel move to the conduction band of SnSe<sub>2</sub>, as mentioned above (Fig. 2b). Since the reversed  $V_d$  enhances the electric field in the heterojunction area, Fig. 2e exhibits a larger  $I_{\text{ph}}$  ( $\sim 50$  times larger than that in Fig. 2d) throughout the entire heterojunction. In contrast, while the device is at forward bias with a negative gate voltage, Pd can efficiently inject holes into WSe<sub>2</sub>, which can overcome the thermionic barrier and reach the source contact. In addition, the band bending at the heterojunction is released, leading to small  $I_{\text{ph}}$  generation in the heterojunction (Fig. 2f). Due to the fact that the direction of the built-in field at the drain part is the same as that of the external field, around  $I_{\text{ph}} = 1$   $\mu$ A is generated at the drain contact and the direction is towards the drain part.

The detailed photoresponse behavior of our device under a  $\lambda = 532$  nm laser is also studied (Fig. 3). Note that, all the measurements are carried out by locating the laser spot at the heterojunction where the largest photocurrent is generated (Fig. 2e). The time-dependent  $I_{\text{ph}}$  under pulsed light illumination ( $\lambda = 532$  nm, 10  $\mu$ W) is firstly tested at  $V_g = 0$  V and  $-70$  V with different bias voltages, respectively, shown in Fig. 3a. The steep rise and fall edges indicate the fast response of the device. The device shows the photodiode-like behavior, where the  $I_{\text{ph}}$  increases significantly when it is at reverse bias compared with that of forward bias both at  $V_g = 0$  V and  $-70$  V. This can be explained by the fact that the increased band





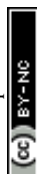
**Fig. 2** Operation principle of our heterojunction device. (a–c) Band diagram of heterojunction and Schottky junctions, where (a)  $V_g = V_d = 0$  V, (b)  $V_g = -70$  V,  $V_d = -1$  V and (c)  $V_g = -70$  V,  $V_d = 1$  V. The red/purple arrows indicate the carrier movement direction. The magenta arrows indicate the separation process of electron–hole pairs. The pink rectangular regions indicate the position of the strongest built-in electric field. (d–f) Photocurrent mapping of the heterojunction under different bias conditions at 532 nm.  $P_{laser} = 50$   $\mu$ W ( $8.5 \times 10^3$  W cm<sup>-2</sup>). The dashed lines outline the flakes and heterojunction. The scale bar is 10  $\mu$ m.

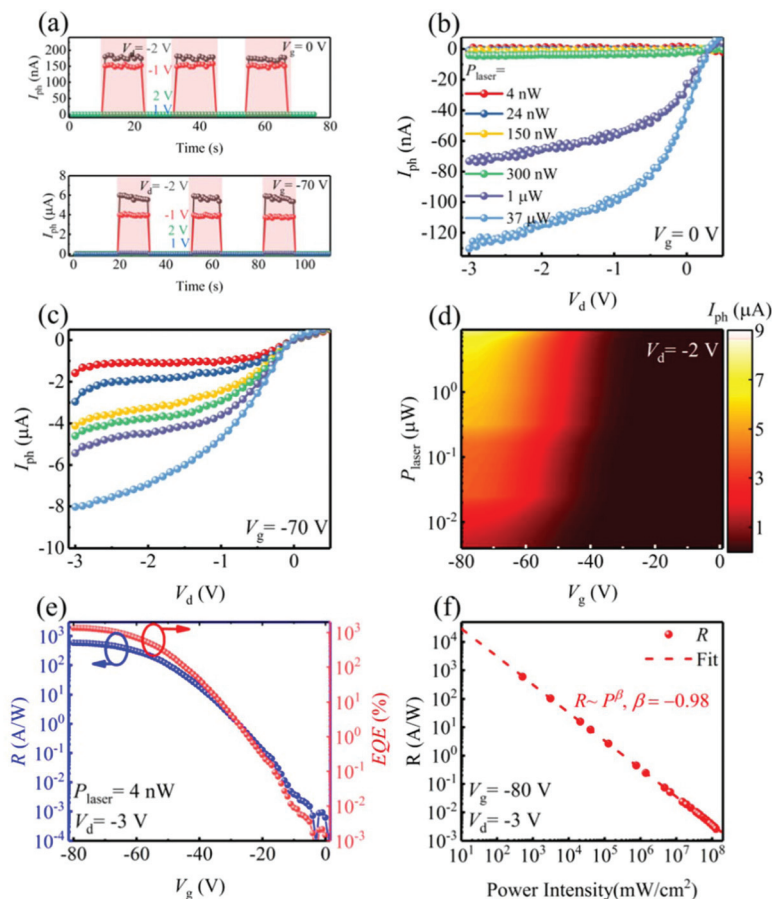
bending under the reverse bias conditions results in the efficient separation of the photo-generated electron–hole pairs, which coincides with our photocurrent mapping results (Fig. 2e and f). Since the forward bias results in a much lower  $I_{ph}$  compared with that from reverse bias, in the following discussion we will only focus on the  $I_{ph}$  under the condition of the reverse bias voltage.

Fig. 3b and c illustrate the  $I_{ph}$ - $V_d$  curves of the heterostructure with fixed gate voltages ( $V_g = 0$  V and  $V_g = -70$  V, respectively) under the  $\lambda = 532$  nm laser with the laser power varying from 4 nW to 37  $\mu$ W. The magnitude of the  $I_{ph}$  strongly depends on the  $V_d$ , due to the increased carrier drift velocity and the increased charge carrier separation efficiency, suggesting that a higher photocurrent can be readily achieved by applying a larger reversed  $V_d$ . With the increase in the  $P_{laser}$ , the  $I_{ph}$  at reverse bias increases and approaches 8  $\mu$ A at  $V_d = -3$  V and  $V_g = -70$  V (Fig. 3c). Moreover, since the larger reversed  $V_d$  and  $V_g$  will lead to the larger electric field at the heterojunction region, the efficiency of the photo-excited carrier separation increases, resulting in a  $\sim 62$ -fold increase of  $I_{ph}$  ( $P_{laser} = 37$   $\mu$ W,  $V_d = -3$  V) at  $V_g = -70$  V compared with that

at  $V_g = 0$  V. The  $I_{ph}$  as a function of  $V_g$  and  $P_{laser}$  is plotted in Fig. 3d. Clearly, the  $I_{ph}$  increases with the decreasing of the gate voltage and a higher incident laser power. For example, when  $P_{laser} = 1$   $\mu$ W, the photocurrent is remarkable ( $\sim 2$   $\mu$ A) under the condition of  $V_g < -40$  V, confirming that a smaller  $V_g$  leads to a larger photocurrent.

To better understand the photoresponse properties of our device, several important figures of merit for photodetectors are studied, including the photoresponsivity ( $R = I_{ph}/P_{laser}$ ), detectivity ( $D = R \times s^{1/2}/(2 \times q \times I_{dark})^{1/2}$ ) and external quantum efficiency (EQE =  $(I_{ph}/q)/(P_{laser}/h\nu)$ ), where  $q$  is the electron charge,  $s$  is the illumination area,  $I_{dark}$  is the current when the laser is off and  $h\nu$  is the photon energy.<sup>17</sup> The gate-dependent  $R$  and EQE are shown in Fig. 3e. With a decrease in the  $V_g$ , the largest  $R$  and EQE could reach 588 A W<sup>-1</sup> and 1367%, respectively, benefiting from the increased band bending which has been mentioned above. An EQE larger than 100% has been previously observed, which is might due to the photo-excited carriers being recirculated many times before reaching the electrodes resulting from the long carrier lifetime.<sup>50,58</sup> The highest  $D$  is estimated to be  $4.4 \times 10^{10}$  Jones. The corresponding  $R$  as a





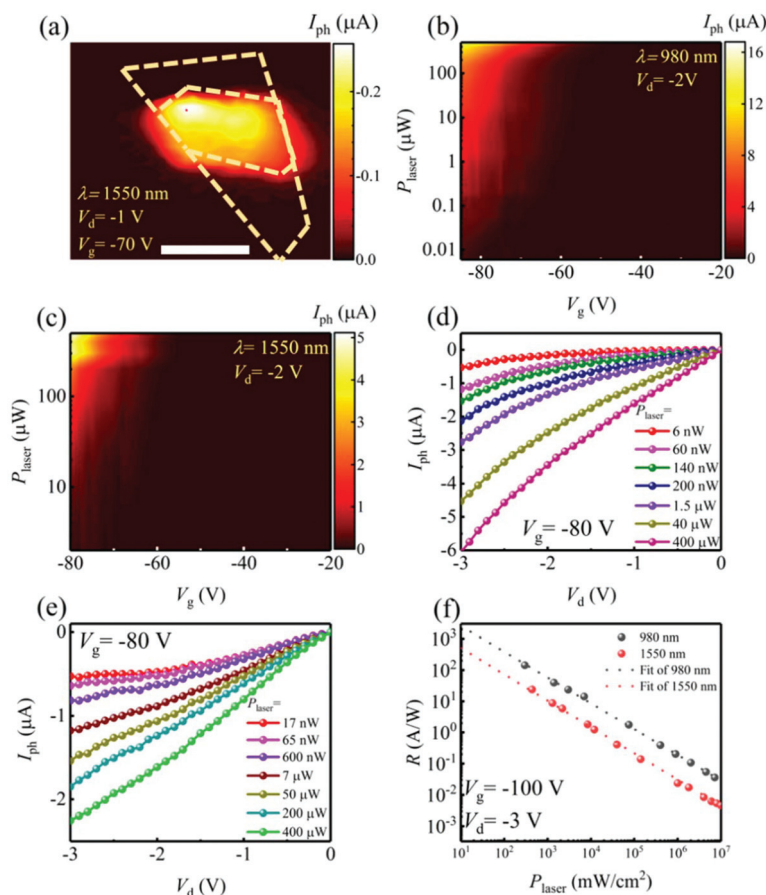
**Fig. 3** Photoresponse of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterojunction device at 532 nm. (a) Photo-switching characteristics at different  $V_d$ .  $I_{ph}$ - $V_d$  characterization of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterojunction at (b)  $V_g = 0$  V and (c)  $V_g = -70$  V. (d)  $I_{ph}$  dependence of the  $V_g$  and  $P_{laser}$ . (e)  $R$  and EQE dependence of  $V_g$ . (f)  $R$  measured with different input power intensities.

function of the incident power intensity is summarized in Fig. 3f. It is clearly observed that the  $R$  linearly changes with the  $P_{laser}$  in the log scale. By fitting the experimental data with the equation of  $R \sim P^\beta$ , the term  $\beta$  is obtained at  $-0.98$  for 532 nm, indicating the superior photocurrent capability and excellent separation efficiency of photo-induced charge carriers.

Telecommunication wavelength detection is an important issue for various applications. Here, we test our heterojunction device at telecommunication wavelengths. The spatially resolved photocurrent mapping with a  $\lambda = 1550$  nm laser ( $V_d = -1$  V,  $V_g = -70$  V and  $P_{laser} = 10$  μW) reveals pronounced photocurrent generation in the overlapped region (Fig. 4a). Fig. 4b and c depict the gate-dependent photoresponse of the device under 980 nm and 1550 nm lasers, where  $I_{ph}$  shows the same tendency as that at 532 nm. However, a threshold for the near-infrared photon detection can be observed. For example, under the bias conditions,  $V_d = -2$  V and  $P_{laser} = 10$  μW, for  $\lambda = 980$  nm, the photocurrent is not detectable when the  $V_g$  is larger than  $-60$  V. As for the incident light at  $\lambda = 1550$  nm, under the same bias conditions, this threshold voltage shifts to  $V_g = -70$  V. This fascinating phenomenon can be attributed to the tunneling-assisted transition in the band-bending het-

erohunction: an extremely negative gate voltage and a high reverse bias voltage increase the built-in electric field at the heterojunction, and the edges of the conduction band and valence band are tilted along the direction of the electric field. The electron and hole wave functions have a tail which extends into the band gap, enhancing the e-h interactions with sub-bandgap photons.<sup>59</sup> Thus, under such a high built-in electric field, our device has the potential to allow the photo-excited carrier generation with a photon energy smaller than the intrinsic band-gap of WSe<sub>2</sub> and transfer to the conduction band of SnSe<sub>2</sub>.<sup>53,60</sup> The magnitude of the photocurrent under the 980 nm laser is around 2.6 times larger than that generated under the 1550 nm laser because the photon energy of 980 nm is higher than that of 1550 nm. Note that there is no photoresponse of our device when it is forward biased even when the device is exposed to an intense light. Fig. 4d and e show the  $I_{ph}$ - $V_d$  curves of the heterostructure with a fixed gate voltage ( $V_g = -70$  V) under the  $\lambda = 980$  nm and 1550 nm lasers with the laser power varying from 6 nW to 400 μW and 17 nW to 400 μW, respectively. The magnitude of the  $I_{ph}$  shows strong dependence on the reverse bias voltage. This results from the larger built-in electric field at the larger reverse bias voltage.





**Fig. 4** Photoreponse of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterojunction device at 980 nm and 1550 nm. (a) Photocurrent mapping of the heterojunction under different bias conditions at 1550 nm.  $P_{laser} = 10 \mu\text{W}$  ( $2 \times 10^5 \text{ mW cm}^{-2}$ ).  $I_{ph}$  dependence of the  $V_g$  and  $P_{laser}$  at (b) 980 nm and (c) 1550 nm.  $I_{ph}$ - $V_d$  characterization of the WSe<sub>2</sub>/SnSe<sub>2</sub> heterojunction at (d) 980 nm and (e) 1550 nm. (f)  $R$  at different input power intensities. The scale bar is 10  $\mu\text{m}$ .

Fig. 4f depicts the  $R$  of the device under  $\lambda = 980$  and 1550 nm as a function of the laser intensity. The maximum  $R$  of our device (according to the fitting results) is  $396 \text{ A W}^{-1}$  at 980 nm ( $P_{laser} = 100 \text{ mW cm}^{-2}$ ) and is  $80 \text{ A W}^{-1}$  at 1550 nm ( $P_{laser} = 100 \text{ mW cm}^{-2}$ ). The  $R$  at the visible wavelength and telecommunication wavelength range is superior to those of the previously reported 2D materials and their heterostructure based photodetectors (see ESI Fig. S4†). The highest detectivity and EQE at these two wavelengths are  $4.4 \times 10^{10}$  Jones, 500% and  $1.4 \times 10^{10}$  Jones, 64%, respectively. The time-dependent  $I_{ph}$  under pulsed light illumination (at 1550 nm) is determined (ESI Fig. S5†). The rise time and the decay time are 16 and 45 ms, respectively. We believe that the speed of the device can be further improved by improving the crystal quality.

## Conclusions

In summary, we report a high-sensitivity and broadband few-layer WSe<sub>2</sub>/SnSe<sub>2</sub> heterostructure based photodetector. The band-to-band tunneling mechanism allows the proposed device to detect light from visible to telecommunication wavelengths. The highest responsivity and detectivity at 532 nm are

$588 \text{ A W}^{-1}$  and  $4.4 \times 10^{10}$  Jones and those at 1550 nm are  $80 \text{ A W}^{-1}$  and  $1.4 \times 10^{10}$  Jones, which outperform the state-of-art 2D materials based photodetectors. Our work shows an attractive platform for practical applications of utilizing few-layer TMD based heterojunctions for high-performance optoelectronic devices (such as modulators<sup>61,62</sup> and lasers).<sup>63–68</sup>

## Conflicts of interest

There are no conflicts to declare.

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